



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

December 5, 2025

IGI Report Number **LG755508815**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **ROUND BRILLIANT**

Measurements **7.96 - 8.04 X 5.01 MM**

GRADING RESULTS

Carat Weight **2.00 CARATS**

Color Grade **E**

Clarity Grade **VS 2**

Cut Grade **IDEAL**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

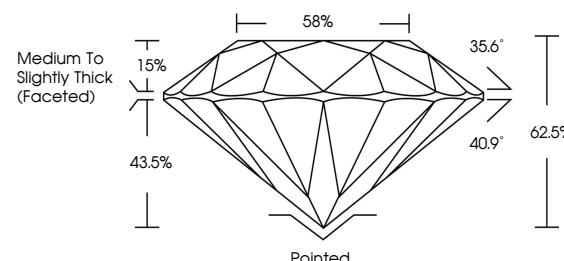
IGI **LG755508815**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

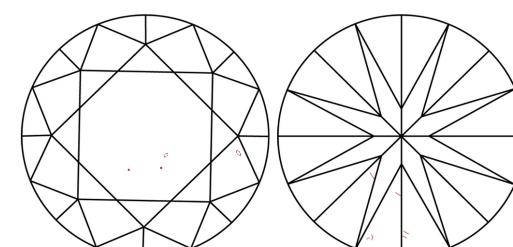
Type Ila

LG755508815
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

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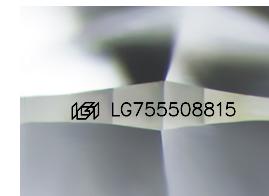
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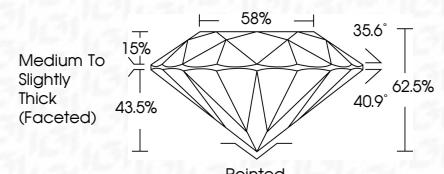
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Sample Image Used



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Inscription(s) **IGI LG755508815**

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December 5, 2025	IGI Report No LG755508815	ROUND BRILLIANT	E
7.96 - 8.04 X 5.01 MM	Carat Weight	VS 2	IDEAL
	Color Grade	0.25%	0.89%
	Clarity Grade	IDEAL	IDEAL
	Cut Grade	IDEAL	IDEAL
	Depth	IDEAL	IDEAL
	Table	IDEAL	IDEAL
	Girdle	IDEAL	IDEAL
	Medium To Slightly Thick (Faceted)	IDEAL	IDEAL
	Pointed	IDEAL	IDEAL
	Excellent	Excellent	None
	Excellent	Excellent	None
	Fluorescence	None	None
	Inscription(s)	IGI LG755508815	IGI LG755508815

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IGI